



**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1763**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Confirmation No.: 1605

OHMI et al.

Art Unit: 1763

Application No.: 09/864,376

Examiner: R. Zervigon

Filed: May 25, 2001

Docket No.: 107176-00007

For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**Introductory Comments**

Director of the U.S. PTO  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

December 22, 2005

Sir:

In response to the Office Action dated September 28, 2005, please enter the following amendments:

TECH/389388.1

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